



EFW

PATENT
0630-1350P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Jae-Gyung AHN Conf.: 9773
Appl. No.: 09/989,415 Group: 2825
Filed: November 21, 2001 Examiner: C. LYTTLE
For: DEVICE ISOLATION STRUCTURE FOR
SEMICONDUCTOR DEVICE AND METHOD OF
FABRICATING THE SAME

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

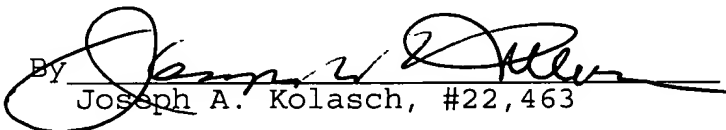
Please advise the undersigned as to the status of the above-identified application as follows:

A duplicate copy of the present Status Inquiry is attached hereto. It is respectfully requested that the duplicate copy be marked appropriately to indicate the status of the above-identified application and returned to the undersigned as soon as possible.

Please call Sharon Perry, at 703-205-8090 extension 6666 if there are any questions with regard to the present request.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By 
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- ☒ Awaiting Action from Patent Office Examiner - Expected Date for Action is: _____.
- ☐ Awaiting Decision by Board of Appeals.
- ☐ Application allowed on _____.
- ☐ Abandoned per _____.
- ☐ Other _____.